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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Aaron Frank, et al. Docket No.: TI-33974
Serial No.: 10/645,975 Art Unit: 1742
Filed: August 22, 2003 Examiner: William T. Leader
Customer No. 23494 Conf. No.: 8382
For: System for In Situ Seed Layer Remediation

CERTIFICATION OF FACSIMILE TRANSMISSION

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NAME OF INVENTOR(S):		
Aaron Frank, et al.		
TITLE OF INVENTION:		
System for In Situ Seed Layer Remediation		
TI FILE NO.:	DEPOSIT ACCT. NO.:	
TI-33974	20-0668	
FAXED:	12/15/2005	
DUE:	12/25/2005	
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RECEIPT DATE & SERIAL NO.:		
Serial No.: 10/645,975		
Filing Date: August 22, 2003		

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	Aaron Frank, et al.	Docket No.:	TI-33974
Serial No:	10/645,975	Filed:	August 22, 2003
Art Unit:	1742	Examiner:	William T. Leader
Customer No.:	23494	Conf. No.:	8382
Title:	System for In Situ Seed Layer Remediation		

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ELECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF FAX TRANSMITTAL	
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	<u>12-15-05</u>
Marianna Smith	Date

Dear Sir:

With respect to the Restriction Requirement mailed on 11/28/2005, the Examiner has restricted the instant application to the invention of Group I (Claims 1-17), or Group II (Claims 18-21). In light of this, Applicants elect to pursue Group I, (Claims 1-17) without traverse.

Respectfully submitted,



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